



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79289

Masayuki TAKASHIMA, et al.

Appln. No.: 10/750,971

Group Art Unit: 1751

Confirmation No.: 1869

Examiner: Brian P. Mruk

Filed: January 5, 2004

For: CLEANING SOLUTION FOR SEMICONDUCTOR SUBSTRATE

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 7, 2006, please amend the above-identified application as follows on the accompanying pages. A petition for an extension of time is submitted herewith, extending the due date for response to June 7, 2006.

TABLE OF CONTENTS

AMENDMENTS TO THE CLAIMS	2
REMARKS	6